

Figure 1A

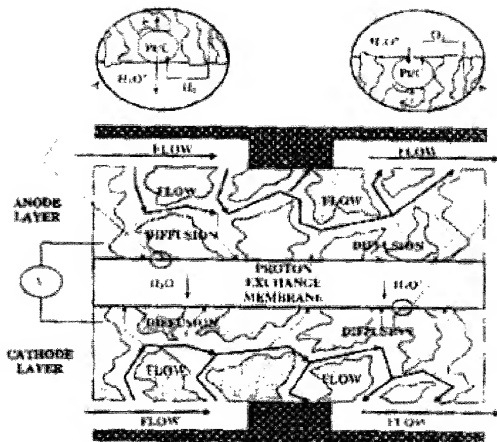


Figure 1B

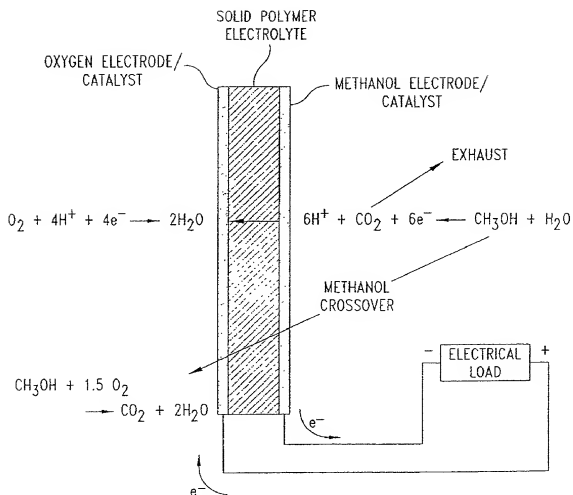


Fig. 2
(Prior Art)

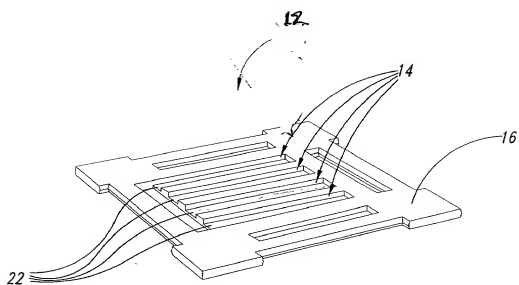


Fig. 3

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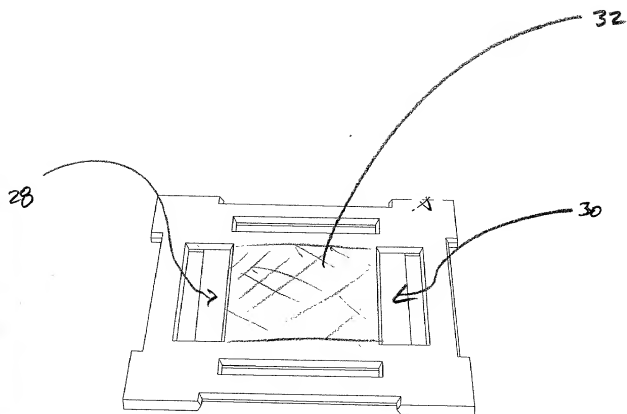


Fig. 4

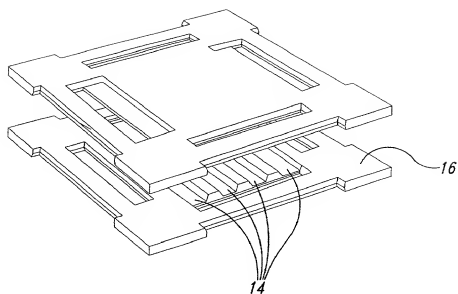


Fig. 5

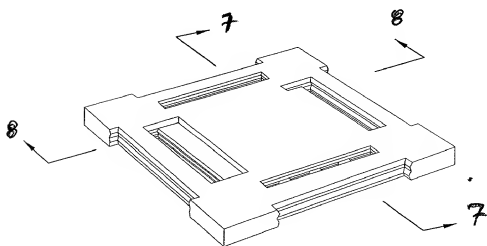


Fig. 6

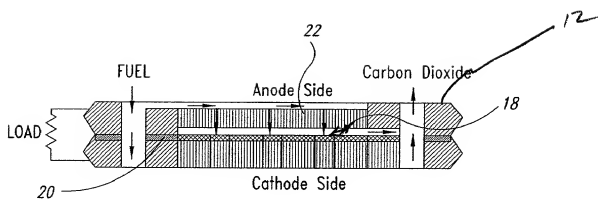


Fig. 7

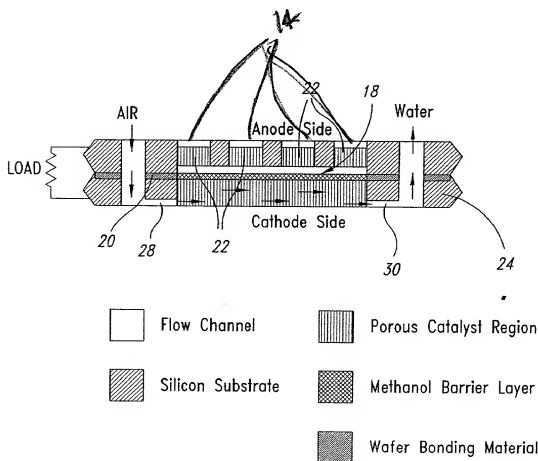
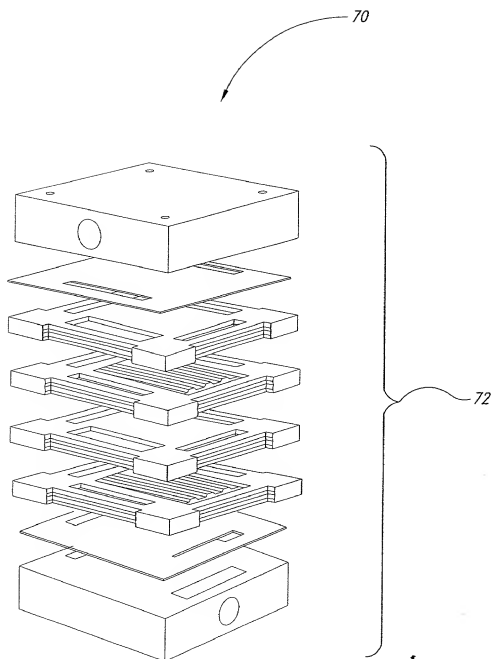


Fig. 8

*Fig. 9*

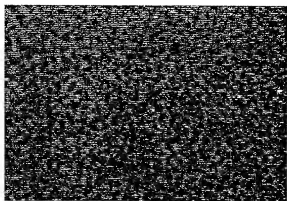


Fig 10A

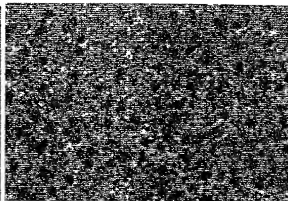


Fig 10B

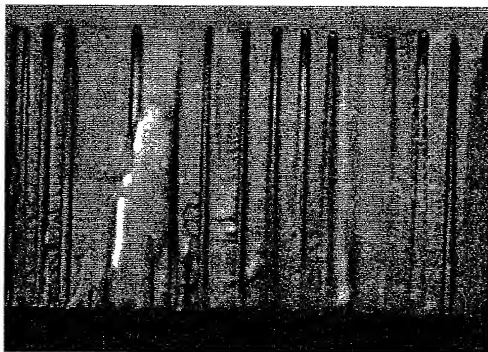


Fig 11

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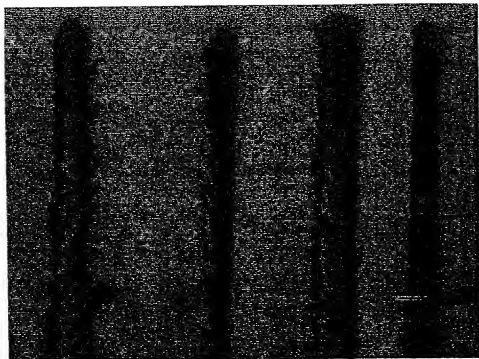


Fig. 12

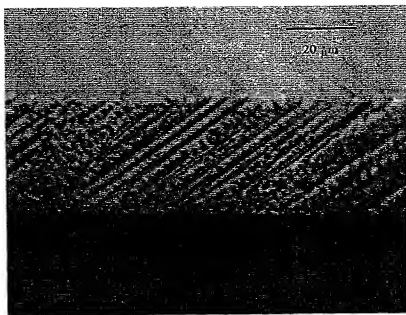


Fig. 13

09858327-051501

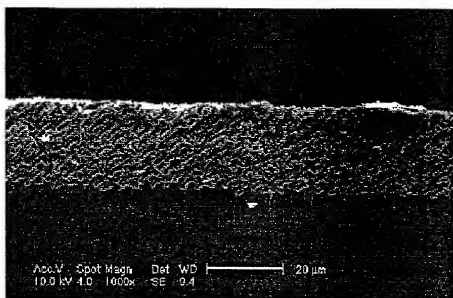


Fig. 14

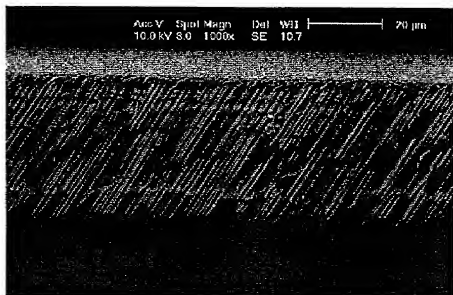


Fig. 15

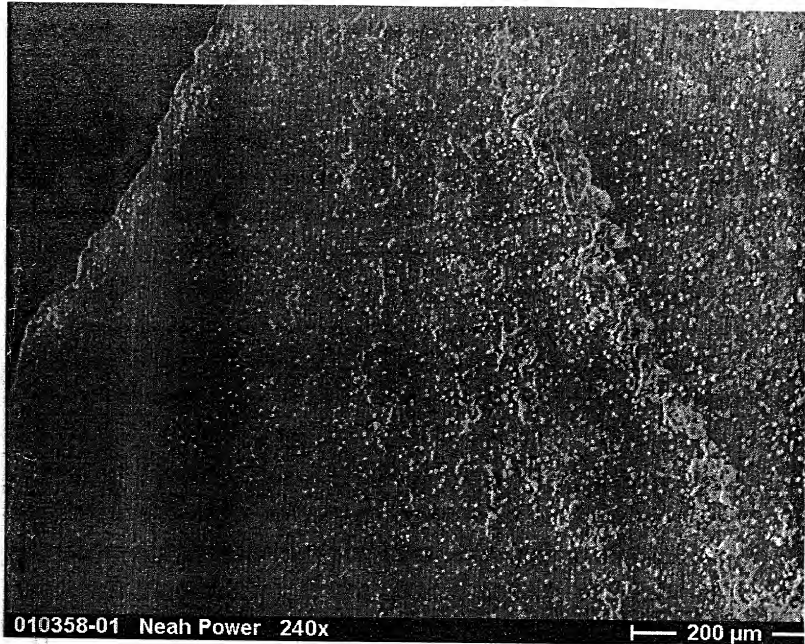


Fig. 1/2/6

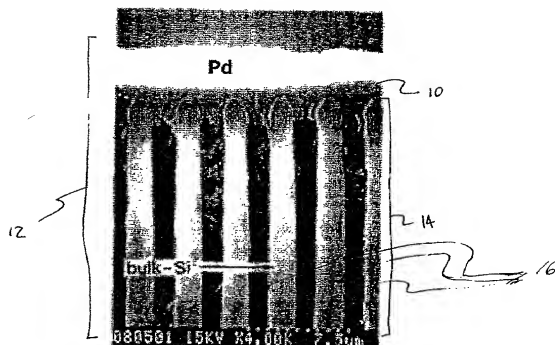


Figure ~~16~~ 17

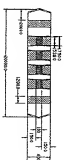
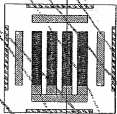


Fig 14
Cross Section A



~~Cross Section B~~

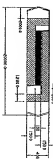


Fig 19c

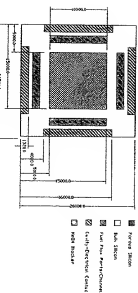


Fig 20A

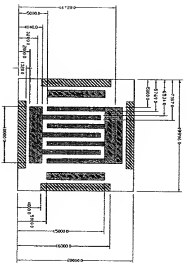
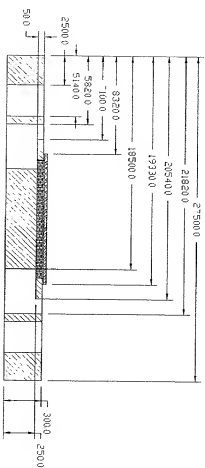


Fig 20B

Bottom View - Cathode Electrode



☒ Silicon Substrate
☒ Porous Silicon
☐ Fuel Flow Ports/Channel
☐ Pt Layer

Fig 21

21

Fig 21

09858327-051501

22A-D

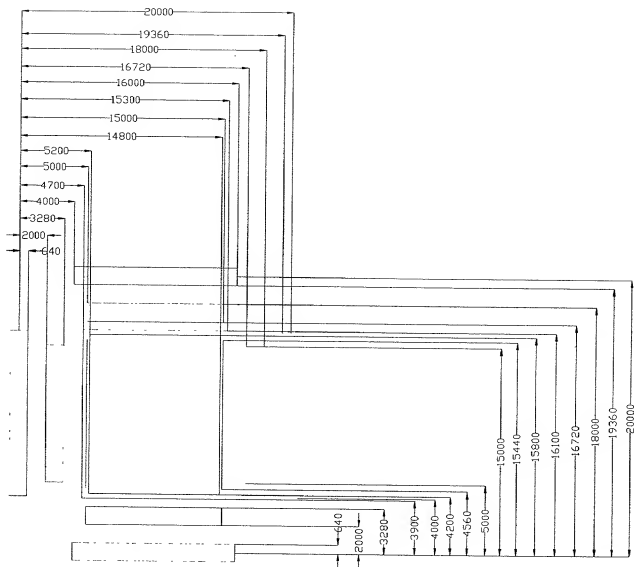
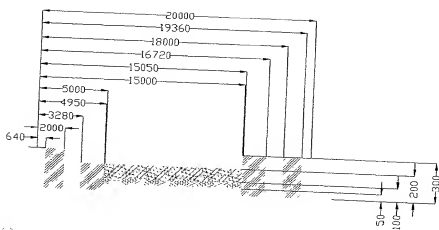


Fig 22A

Top View X, Y, Z, S, C



S. C. V. 2.

Fig. 22B

2000

100

Silene

$\frac{d}{dt} \left(\frac{\partial L}{\partial \dot{x}} \right) = \frac{\partial L}{\partial x}$

[Faint handwritten notes]

1001501 2299860

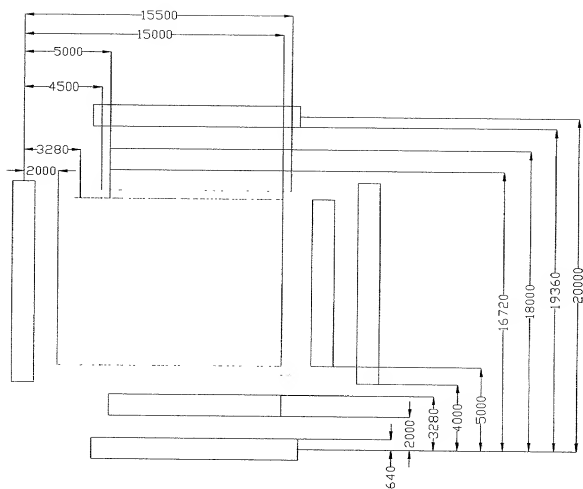
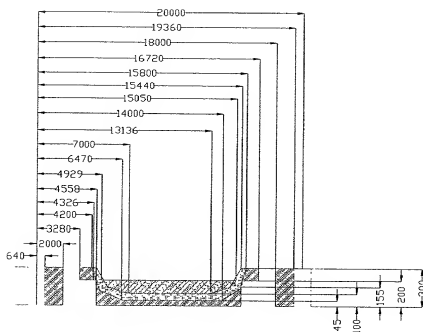


Fig. 22C

105150-2285860



- 1. 105150-2285860
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- 99. 105150-2285860
- 100. 105150-2285860

Fig. 22P

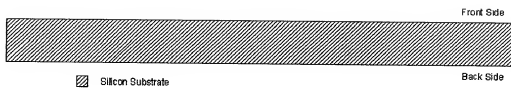


Figure 23

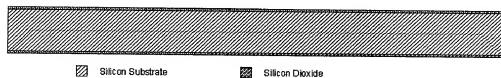


Figure 24

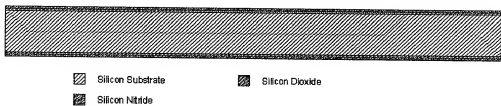


Figure 25

09858327-051504

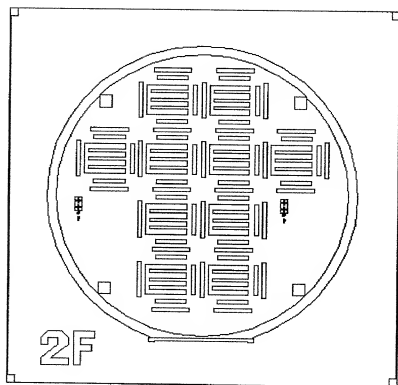
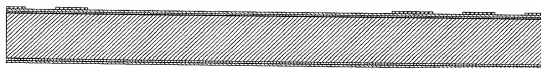
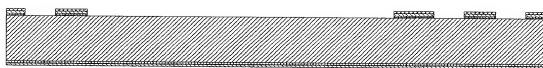


Figure 26A



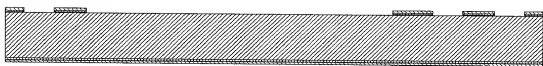
- | | |
|---|---|
|  Silicon Substrate |  Photoresist |
|  Silicon Nitride |  Silicon Dioxide |

Figure 26B



- | | |
|---|---|
|  Silicon Substrate |  Photoresist |
|  Silicon Nitride |  Silicon Dioxide |

Figure 27




- | | |
|---|---|
|  Silicon Substrate |  Silicon Dioxide |
|  Silicon Nitride | |

Figure 28

09888327.051501

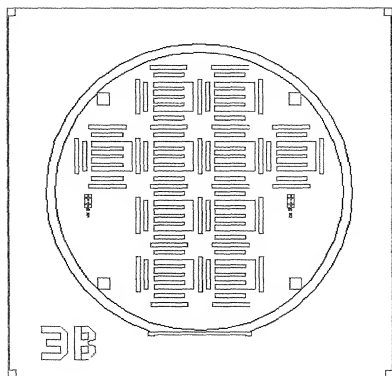


Figure 29A

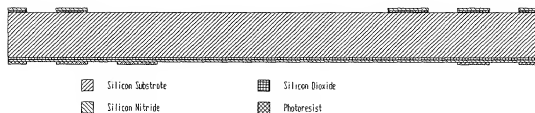


Figure 29B

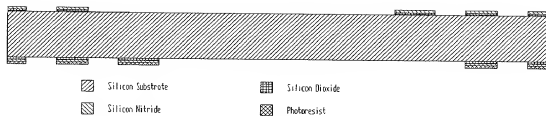


Figure 30

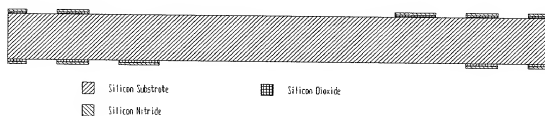


Figure 31

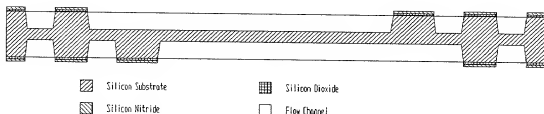


Figure 32

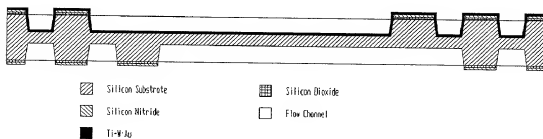


Figure 33

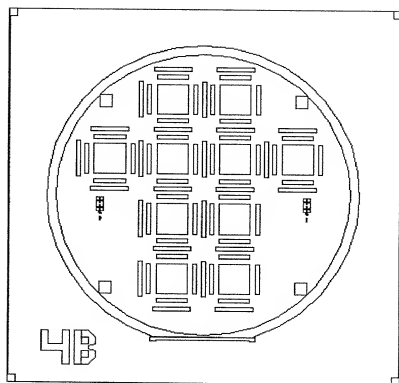


Figure 34A



- | | |
|-------------------|-----------------|
| Silicon Substrate | Silicon Dioxide |
| Silicon Nitride | Flow Channel |
| Ti-W-Au | Photoreist |

Figure 34B



- | | |
|-------------------|-----------------|
| Silicon Substrate | Silicon Dioxide |
| Silicon Nitride | Flow Channel |
| Ti-W-Au | Photoreist |
| Ti-W-Au | |

Figure 35

09858327 051504

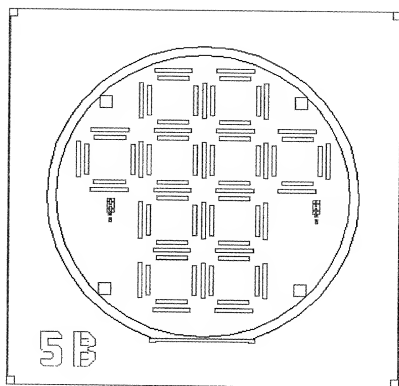


Figure 36A

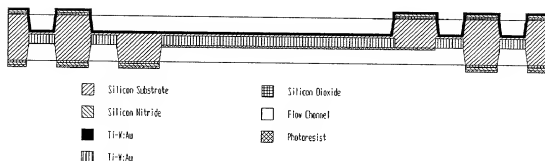


Figure 36B

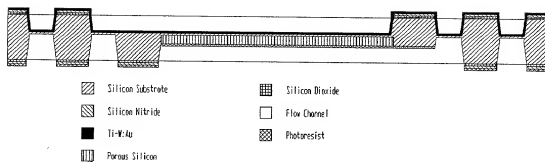


Figure 37

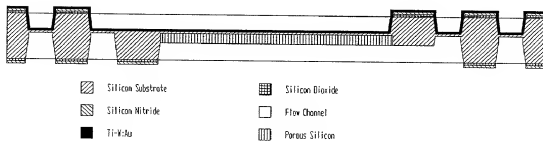


Figure 38

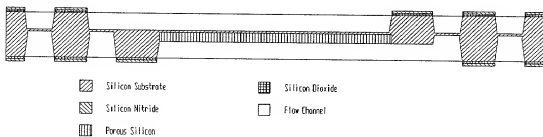


Figure 39

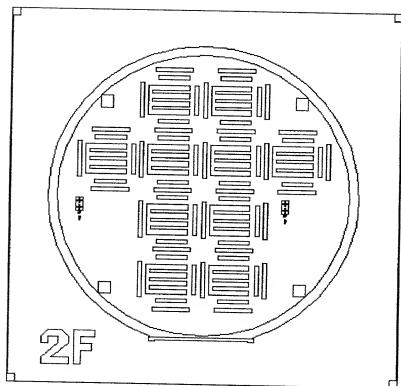


Figure 40A

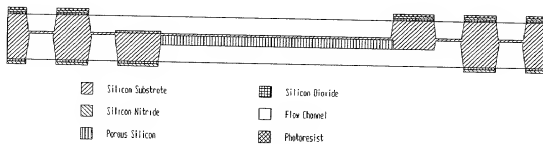


Figure 40B

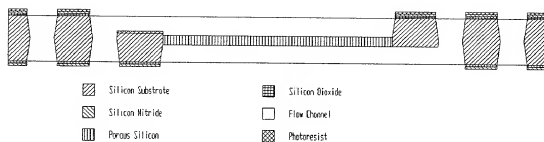


Figure 41

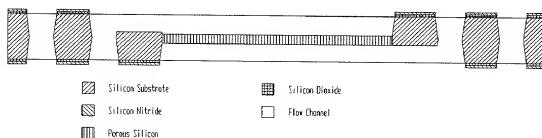


Figure 42

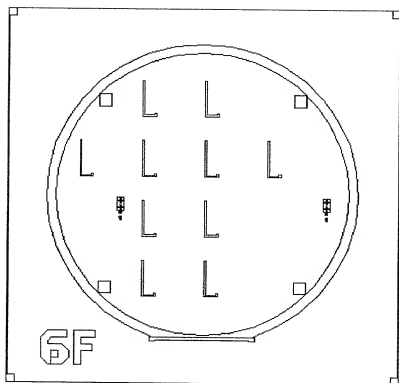


Figure 43A

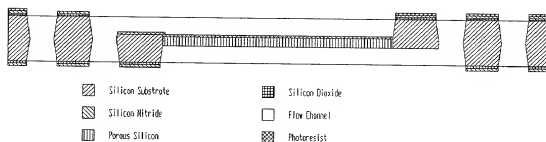


Figure 43B

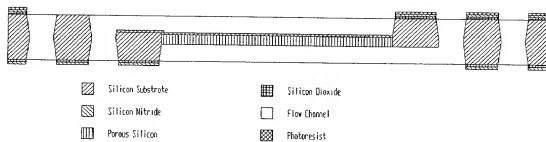


Figure 44

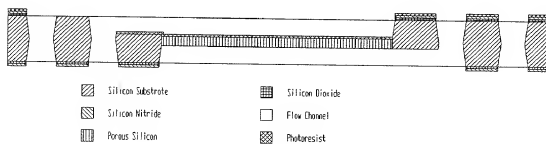


Figure 45

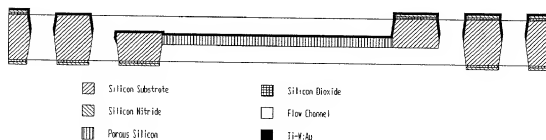


Figure 46

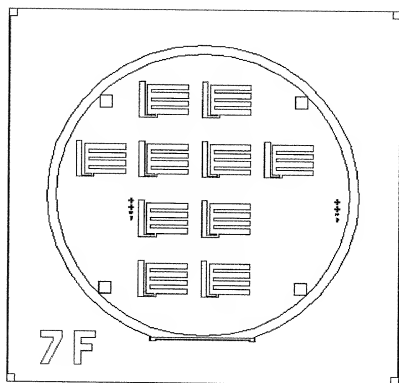


Figure 47A

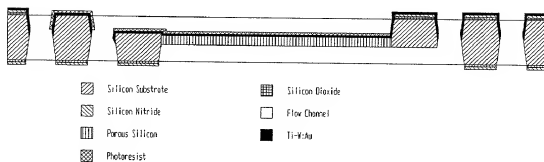


Figure 47B

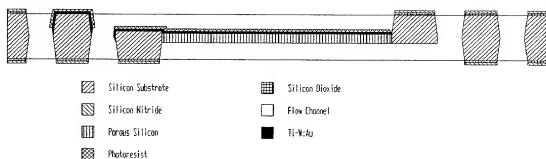


Figure 48

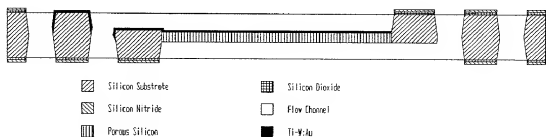


Figure 49

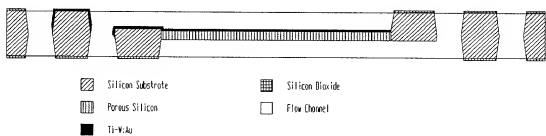


Figure 50

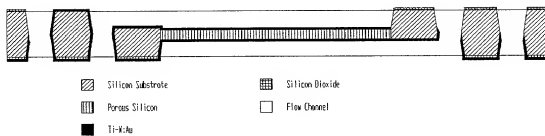


Figure 51

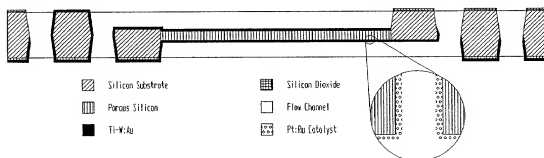


Figure 52

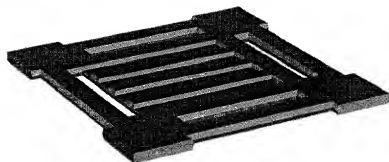


Figure 53A

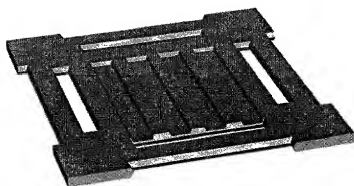


Figure 53B

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09858327 051501




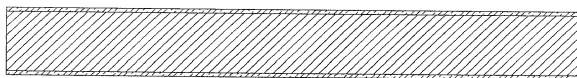

 Silicon Substrate

Figure 54



 Silicon Substrate

 Silicon Nitride

Figure 55

09858327, 051501

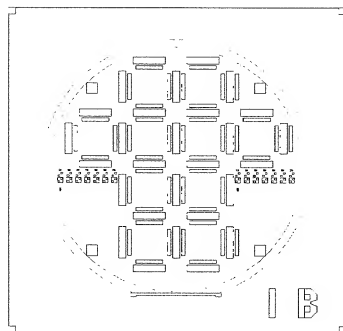
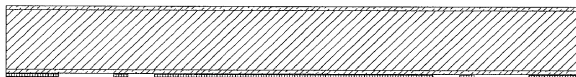


Figure 56A






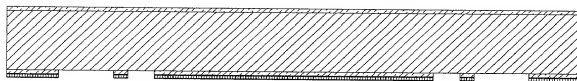
-  Silicon Substrate
-  Silicon Nitride
-  Photo Resists

Figure 56B






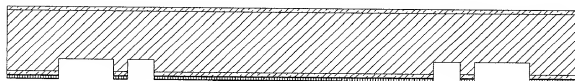
-  Silicon Substrate
-  Silicon Nitride
-  Photo Resists

Figure 59





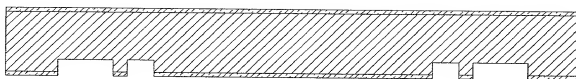
-  Silicon Substrate
-  Silicon Nitride
-  Photo Resists

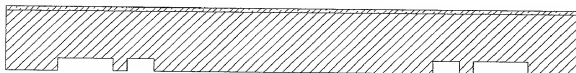
Figure 58



□ Silicon Substrate

▨ Silicon Nitride

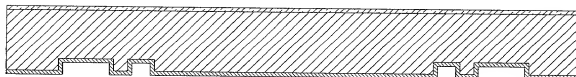
Figure 59



□ Silicon Substrate

▨ Silicon Nitride

Figure 60



□ Silicon Substrate

▨ Silicon Nitride

▩ Aluminum Contact

Figure 61

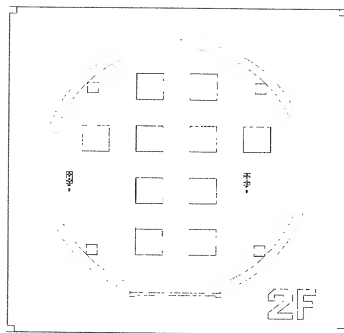
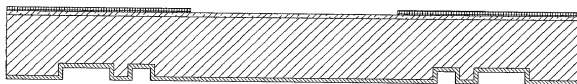


Figure 62A







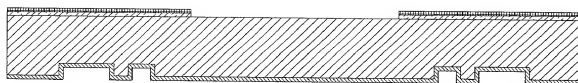
- | | | | |
|---|-------------------|---|---------------|
|  | Silicon Substrate |  | Photo Resists |
|  | Silicon Nitride | | |
|  | Aluminum Contact | | |

Figure 62B







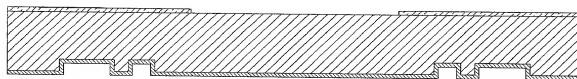
-  Silicon Substrate
-  Photo Resists
-  Silicon Nitride
-  Aluminum Contact

Figure 63






-  Silicon Substrate
-  Silicon Nitride
-  Aluminum Contact

Figure 64







- | | | | |
|---|-------------------|---|----------------|
|  | Silicon Substrate |  | Porous Silicon |
|  | Silicon Nitride | | |
|  | Aluminum Contact | | |

Figure 65








- | | | | |
|---|-------------------|---|----------------|
|  | Silicon Substrate |  | Porous Silicon |
|  | Silicon Nitride | | |

Figure 66



 Silicon Substrate

 Aluminum Contact

 Silicon Nitride

 Porous Silicon

Figure 67

0985027-054504
105150-2285860

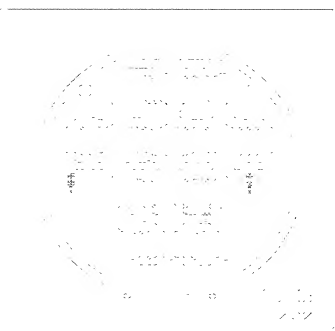
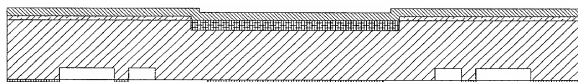


Figure 68A



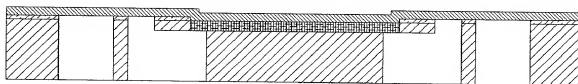
- | | |
|---|--|
|  Silicon Substrate |  Aluminum Contact |
|  Silicon Nitride |  Porous Silicon |
|  Photo Resists | |

Figure 68B



- | | |
|---|--|
|  Silicon Substrate |  Aluminum Contact |
|  Silicon Nitride |  Porous Silicon |
|  Photo Resist | |

Figure 6A



- | | |
|---|--|
|  Silicon Substrate |  Aluminum Contact |
|  Silicon Nitride |  Porous Silicon |

Figure 70






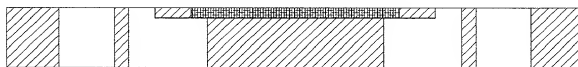
 Silicon Substrate  Porous Silicon
 Silicon Nitride

Figure 71








 Silicon Substrate  Porous Silicon
 Silicon Nitride

Figure 72



 Silicon Substrate
  Porous Silicon




 Metal Seed Layer

Figure 73

09859327.051501

 Silicon Substrate
  Photo Resists



 Metal Seed Layer
  Porous Silicon

Figure 74B







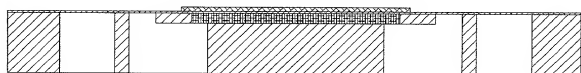
- | | |
|---|--|
|  Silicon Substrate |  Photo Resists |
|  Pd Layer |  Porous Silicon |

Figure 75






- | | |
|---|--|
|  Silicon Substrate |  Porous Silicon |
|  Pd Layer | |

Figure 76

00515072285860

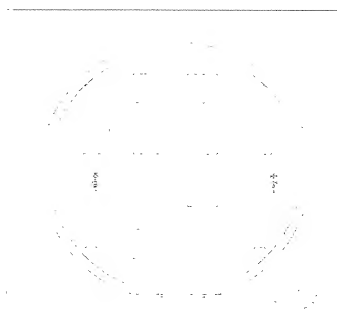


Figure 77A

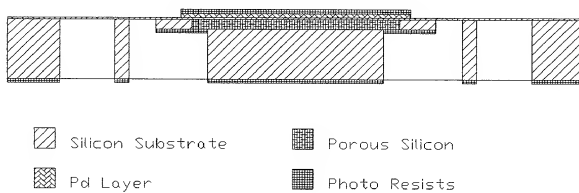
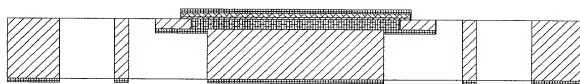


Figure 77B







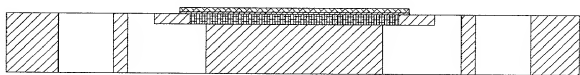
 Silicon Substrate	 Porous Silicon
 Pd Layer	 Photo Resists

Figure 78






 Silicon Substrate	 Porous Silicon
 Pd Layer	

Figure 79

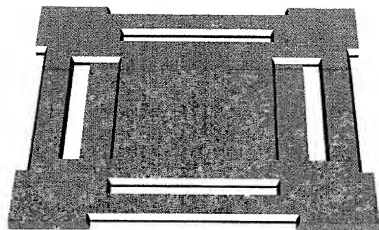


Fig. 80A

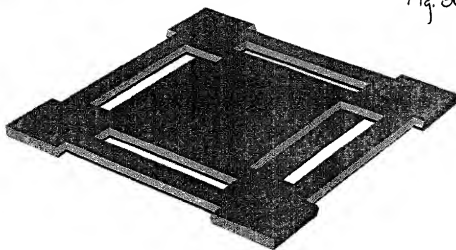


Fig. 80B

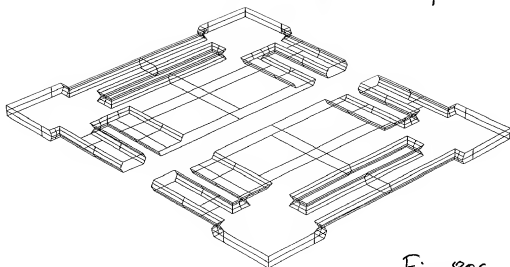
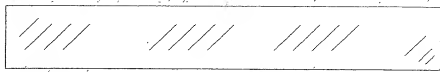


Fig. 80C

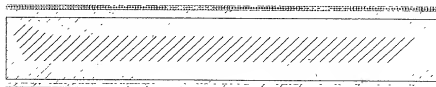
09558327.051504



☐ Silicon Oxide
☒ Silicon Substrate

☒ Silicon Nitride

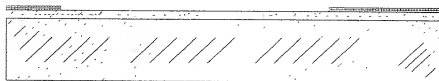
Fig. 81



☐ Silicon Oxide
☒ Silicon Substrate

☐ Silicon Nitride
☒ Photoresist

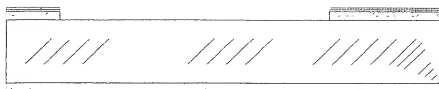
Fig. 82



☐ Silicon Oxide
☒ Silicon Substrate

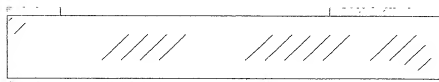
☒ Silicon Nitride
☒ Photoresist

Fig. 83



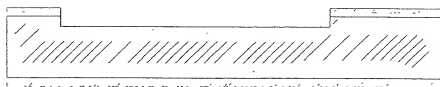
- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input checked="" type="checkbox"/> Photoresist |

Fig. 84



- | | |
|--|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | |

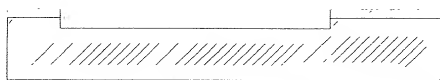
Fig. 85



- | | |
|--|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | |

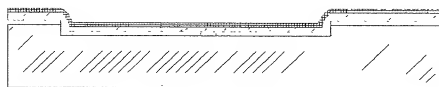
Fig. 86

09858327-051501



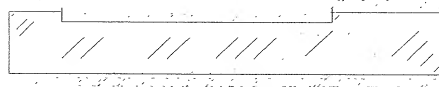
- ☐ Silicon Oxide ☐ Silicon Nitride
☐ Silicon Substrate

Fig. 87



- ☐ Silicon Oxide ☐ Silicon Nitride
☐ Silicon Substrate ☐ Photoresist

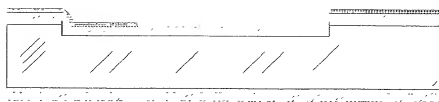
Fig. 88



- ☐ Silicon Oxide ☐ Silicon Nitride
☐ Silicon Substrate

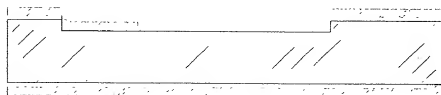
Fig. 89

0958327-051501



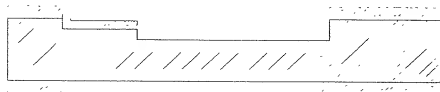
- | | |
|--|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Photoresist |

Fig. 90



- | | |
|---|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | |

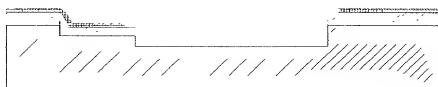
Fig. 91



- | | |
|--|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | |

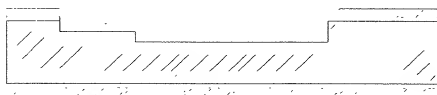
Fig. 92

04958327.051501



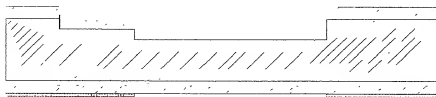
- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input checked="" type="checkbox"/> Photoresist |

Fig. 93



- | | |
|--|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | |

Fig. 94



- | | |
|---|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | <input checked="" type="checkbox"/> Photoresist |

Fig. 95

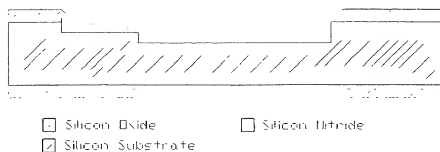


Fig. 96

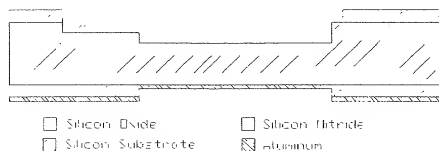


Fig. 97

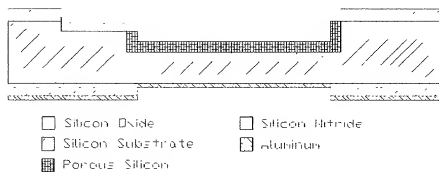
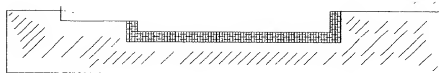


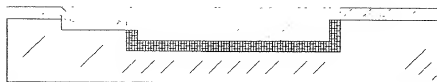
Fig. 98

00058327-051501



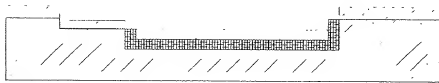
- | | |
|---|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | |
| <input checked="" type="checkbox"/> Porous Silicon | |

Fig. 99



- | | |
|---|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Sol-Gel |
| <input checked="" type="checkbox"/> Porous Silicon | |

Fig. 100



- | | |
|---|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Sol-Gel |
| <input checked="" type="checkbox"/> Porous Silicon | |

Fig. 101

00558327-051501

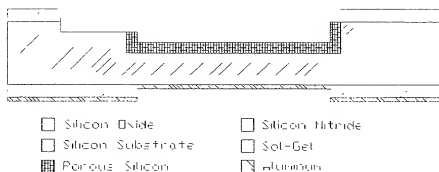


Fig. 102

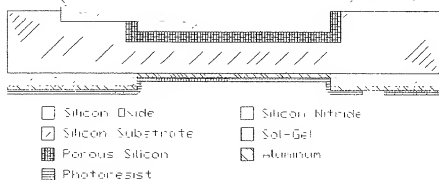


Fig. 103

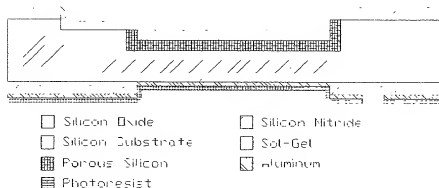
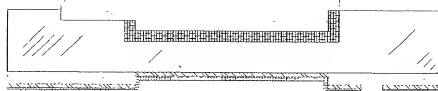
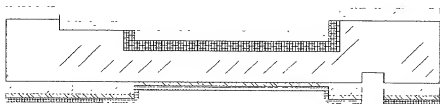


Fig. 104



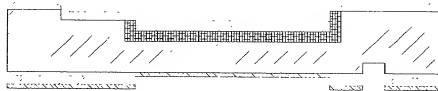
- | | |
|-------------------|-----------------|
| Silicon Oxide | Silicon Nitride |
| Silicon Substrate | Sol-Gel |
| Porous Silicon | Aluminum |
| Photoresist | |

Fig. 105



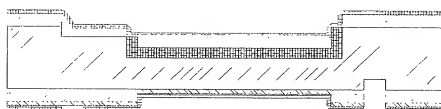
- | | |
|-------------------|-----------------|
| Silicon Oxide | Silicon Nitride |
| Silicon Substrate | Sol-Gel |
| Porous Silicon | Aluminum |
| Photoresist | |

Fig. 106



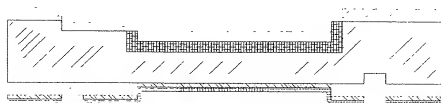
- | | |
|-------------------|-----------------|
| Silicon Oxide | Silicon Nitride |
| Silicon Substrate | Sol-Gel |
| Porous Silicon | Aluminum |

Fig. 107



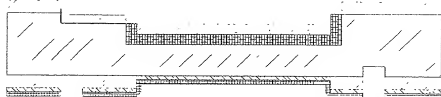
- | | |
|-------------------|-----------------|
| Silicon Oxide | Silicon Nitride |
| Silicon Substrate | Sol-Gel |
| Porous Silicon | Aluminum |
| Photoresist | |

Fig. 108



- | | |
|-------------------|-----------------|
| Silicon Oxide | Silicon Nitride |
| Silicon Substrate | Sol-Gel |
| Porous Silicon | Aluminum |
| Photoresist | |

Fig. 109



- | | |
|-------------------|-----------------|
| Silicon Oxide | Silicon Nitride |
| Silicon Substrate | Sol-Gel |
| Porous Silicon | Aluminum |
| Photoresist | |

Fig. 110

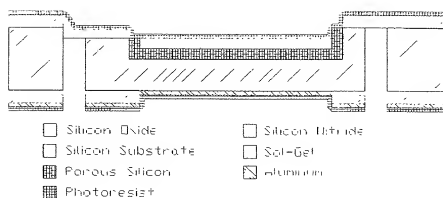


Fig. 111

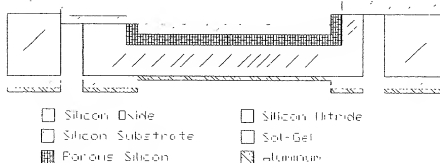


Fig. 112

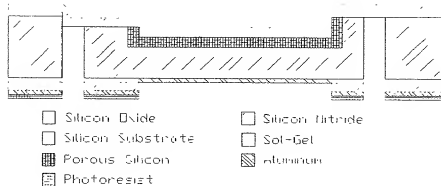


Fig. 113

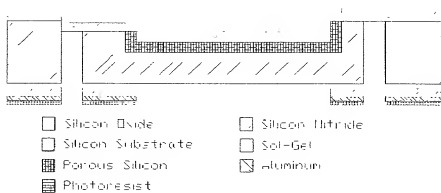


Fig. 114

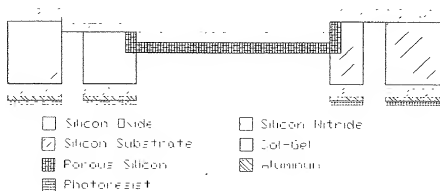


Fig. 115

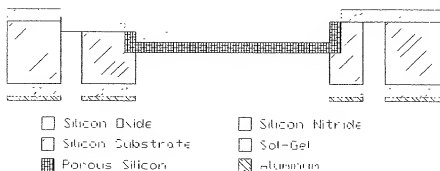


Fig. 116

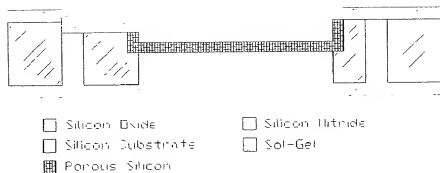


Fig. 117

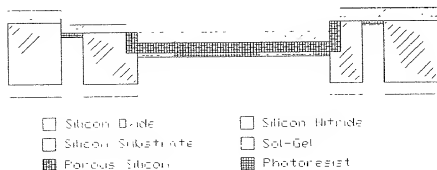


Fig. 118

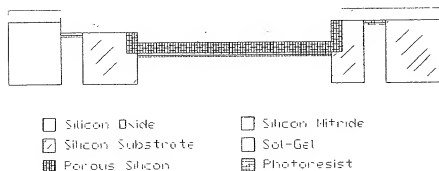


Fig. 119



- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Sol-Gel |
| <input checked="" type="checkbox"/> Porous Silicon | <input checked="" type="checkbox"/> Photoresist |
| <input type="checkbox"/> Titanium | |

Fig. 120



- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Sol-Gel |
| <input checked="" type="checkbox"/> Porous Silicon | <input checked="" type="checkbox"/> Photoresist |
| <input type="checkbox"/> Titanium | <input type="checkbox"/> Gold |

Fig. 121



- | | |
|---|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Sol-Gel |
| <input checked="" type="checkbox"/> Porous Silicon | <input type="checkbox"/> Gold |
| <input type="checkbox"/> Titanium | |

Fig. 122



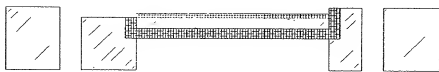
- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Sol-Gel |
| <input checked="" type="checkbox"/> Porous Silicon | <input type="checkbox"/> Gold |
| <input type="checkbox"/> Titanium | <input checked="" type="checkbox"/> Photoresist |

Fig. 123



- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Sol-Gel |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Gold |
| <input checked="" type="checkbox"/> Porous Silicon | <input checked="" type="checkbox"/> Photoresist |
| <input type="checkbox"/> Titanium | |

Fig. 124



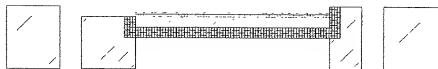
- | | |
|---|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Sol-Gel |
| <input checked="" type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Gold |
| <input checked="" type="checkbox"/> Porous Silicon | <input checked="" type="checkbox"/> Photoresist |
| <input type="checkbox"/> Titanium | |

Fig. 125



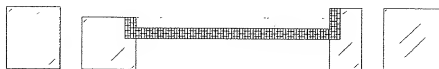
- | | |
|---|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Sol-Gel |
| <input checked="" type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Gold |
| <input checked="" type="checkbox"/> Porous Silicon | <input checked="" type="checkbox"/> Photoresist |
| <input type="checkbox"/> Titanium | |

Fig. 126



- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Sol-Gel |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Gold |
| <input checked="" type="checkbox"/> Porous Silicon | <input checked="" type="checkbox"/> Photoresist |
| <input type="checkbox"/> Titanium | |

Fig. 127



- | | |
|---|-----------------------------------|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Titanium |
| <input checked="" type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Sol-Gel |
| <input checked="" type="checkbox"/> Porous Silicon | <input type="checkbox"/> Gold |

Fig. 128



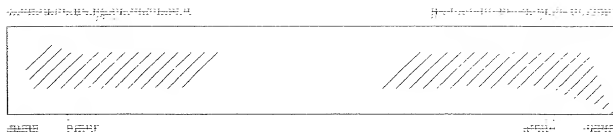
- | | |
|---|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | |
| <input checked="" type="checkbox"/> Photoresist | |

Fig. — 129



- | | |
|---|---|
| <input type="checkbox"/> Silicon Oxide | <input checked="" type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | |
| <input checked="" type="checkbox"/> Photoresist | |

Fig. — 130



- | | |
|---|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | |
| <input checked="" type="checkbox"/> Photoresist | |

Fig. _ _ 131



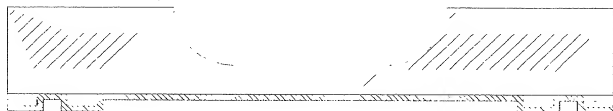
- | | |
|---|---|
| <input type="checkbox"/> Silicon Oxide | <input checked="" type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | |

Fig. _ _ 132



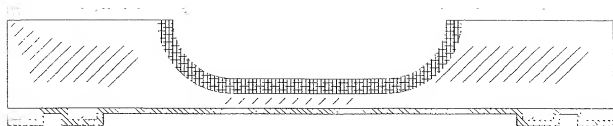
- | | |
|---|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input checked="" type="checkbox"/> Silicon Substrate | <input type="checkbox"/> aluminum |

Fig. _____ 133



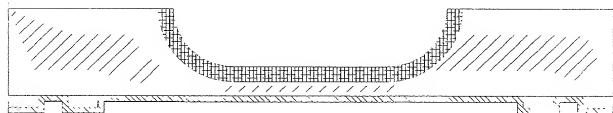
- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input checked="" type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input checked="" type="checkbox"/> aluminum |

Fig. _____ 134



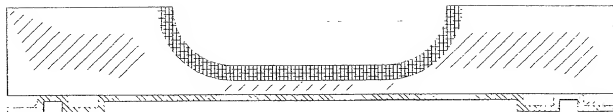
- | | |
|--|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Aluminum |
| <input type="checkbox"/> Porous Silicon | |

Fig. 135



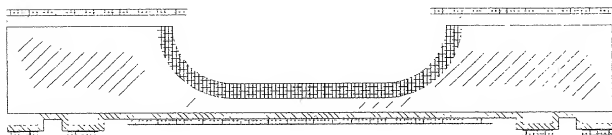
- | | |
|--|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Aluminum |
| <input type="checkbox"/> Porous Silicon | |
| <input type="checkbox"/> Sol-Gel | |

Fig. 136



- | | |
|--|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Aluminum |
| <input type="checkbox"/> Porous Silicon | |
| <input type="checkbox"/> Sol-Gel | |

Fig. 137



- | | |
|--|--|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Aluminum |
| <input type="checkbox"/> Porous Silicon | |
| <input type="checkbox"/> Sol-Gel | |

Fig. 138

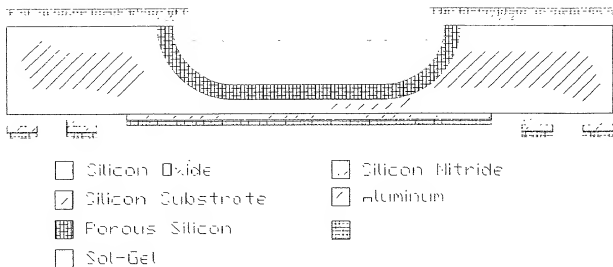


Fig. 139

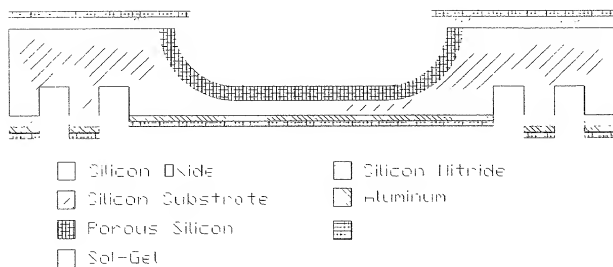


Fig. 140

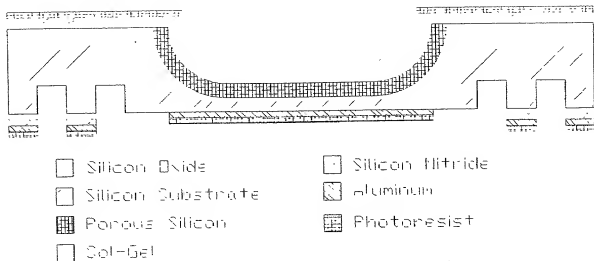


Fig. ____ 141

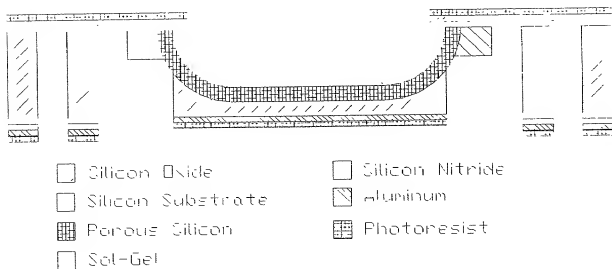
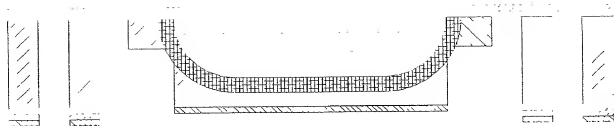


Fig. ____ 142








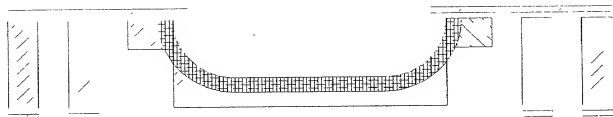
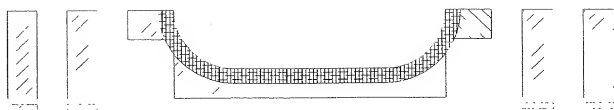
- | | |
|---|---|
|  Silicon Oxide |  Silicon Nitride |
|  Silicon Substrate |  Aluminum |
|  Porous Silicon | |

Fig. ____ 143



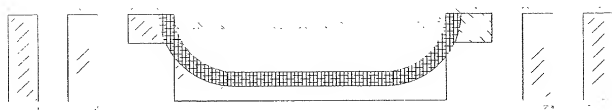
- | | |
|---|---|
|  Silicon Oxide |  Silicon Nitride |
|  Silicon Substrate | |
|  Porous Silicon | |

Fig. ____ 144



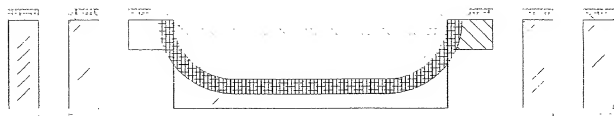
- | | |
|-------------------|-----------------|
| Silicon Oxide | Silicon Nitride |
| Silicon Substrate | |
| Porous Silicon | |

Fig. ____ 145



- | | |
|-------------------|-----------------|
| Silicon Oxide | Silicon Nitride |
| Silicon Substrate | Palladium |
| Porous Silicon | |

Fig. ____ 146









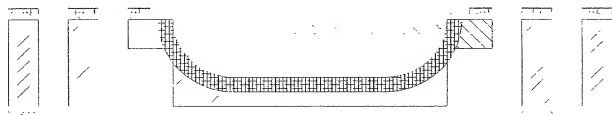
- | | |
|---|---|
|  Silicon Oxide |  Silicon Nitride |
|  Silicon Substrate |  Palladium |
|  Porous Silicon |  Photoresist |

Fig. ____ 147









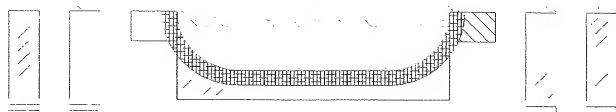
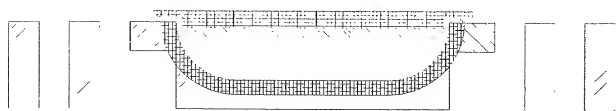
- | | |
|---|---|
|  Silicon Oxide |  Silicon Nitride |
|  Silicon Substrate |  Palladium |
|  Porous Silicon |  Photoresist |

Fig. ____ 148



- | | |
|-------------------|-----------------|
| Silicon Oxide | Silicon Nitride |
| Silicon Substrate | Palladium |
| Porous Silicon | Photoresist |

Fig. ____ 149



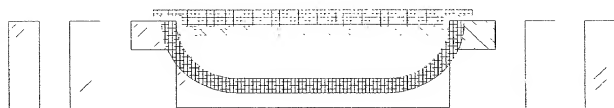
- | | |
|-------------------|-----------------|
| Silicon Oxide | Silicon Nitride |
| Silicon Substrate | Palladium |
| Porous Silicon | Photoresist |
| Sol-Gel | |

Fig. ____ 150



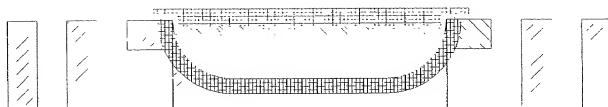
- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Palladium |
| <input checked="" type="checkbox"/> Porous Silicon | <input checked="" type="checkbox"/> Photoresist |
| <input type="checkbox"/> Sol-Gel | |

Fig. 151



- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Palladium |
| <input checked="" type="checkbox"/> Porous Silicon | <input checked="" type="checkbox"/> Photoresist |
| <input type="checkbox"/> Sol-Gel | |

Fig. 152



- | | |
|--|---|
| <input type="checkbox"/> Silicon Oxide | <input type="checkbox"/> Silicon Nitride |
| <input type="checkbox"/> Silicon Substrate | <input type="checkbox"/> Palladium |
| <input checked="" type="checkbox"/> Porous Silicon | <input checked="" type="checkbox"/> Photoresist |
| <input type="checkbox"/> Sol-Gel | <input type="checkbox"/> Ti-Tungsten |
| | <input type="checkbox"/> Gold |

Fig. _____ 153